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Attorney's Docket No.: 42390P10059CD

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application for:

**Ilan Gavish, et al.**

Serial No.: 10/632,582

Filed: July 31, 2003

**For: FOCUSED ION BEAM DEPOSITION**

Examiner: Richard Bueker

Art Group: 1763

Confirmation No.: 5004

**COMMUNICATION REGARDING AMENDMENT AND RESPONSE**  
**TO FINAL OFFICE ACTION**

Mail Stop AF  
Commissioner for Patents  
Post Office Box 1450  
Alexandria, Virginia 22313-1450

Sir:

This is a re-submission of papers previously mailed on March 3, 2005 in response to the Final Office Action mailed November 8, 2004. Applicants respectfully request entry of the amendments set forth in the previous submission, as well as the consideration of the remarks.